



IFW

BOX ISSUE FEE
PATENT
1248-0673P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yutaka TAKAFUJI, et al. Conf. No.: 4125
Appl. No.: 10/668,186 Group: 2813
Filed: September 24, 2003 Examiner: MENZ, Laura Mary
For: SINGLE-CRYSTAL SILICON SUBSTRATE, SOI
SUBSTRATE, SEMICONDUCTOR DEVICE, DISPLAY
DEVICE AND MANUFACTURING METHOD OF
SEMICONDUCTOR DEVICE

LETTER

BOX ISSUE FEE

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Attached hereto please find a Form PTO-SB08 listing references which were cited in a Japanese Office Action mailed October 28, 2008.

Applicant respectfully requests that the attached documents be placed in the application file pursuant to MPEP § 609.04(b).

If the Examiner has any questions concerning this application, the Examiner is requested to contact Robert W. Downs, Reg. No. 48,222 at (703) 205-8000 in the Washington, DC area.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Robert Down # 48222
Charles Gorenstein
Reg. No. 29,271

CG/RWD:cb

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachments: Form SB08